Notice of References Cited Application/Control No. 10/031,399 Examiner Tianjie Chen Applicant(s)/Patent Under Reexamination SATOH, KATSUHISA Page 1 of 1

U.S. PATENT DOCUMENTS

*		. Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	А	US-6,493,308	12-2002	Takamatsu et al.	369/178.01
	В	US-			
	С	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	ì	US-			
	J ·	US-		*	
	К	US-			7
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
	0		,			
	Р					
	Ω		,	***************************************		
	Ŕ					-
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
·	U	
	V	
	w	
	×	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.